

Patent  
Attorney Docket No. 032566-018

IFW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

Otto Z. Zhou et al.

Application No.: 09/996,695

Filing Date: November 30, 2001

Title: DEPOSITION METHOD FOR NANOSTRUCTURE MATERIALS

Group Art Unit: 1753

Examiner: Kishor Mayekar

Confirmation No.: 1828

**FOURTH  
INFORMATION DISCLOSURE STATEMENT  
TRANSMITTAL LETTER**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Enclosed is a FOURTH Information Disclosure Statement and accompanying form PTO-1449 for the above-identified patent application.

- ☒ No additional fee for submission of an IDS is required.
- ☐ The fee of \$180.00 (1806) as set forth in 37 C.F.R. § 1.17(p) is also enclosed.
- ☐ A statement under 37 C.F.R. § 1.97(e) is also enclosed.
- ☐ A statement under 37 C.F.R. § 1.97(e), and the fee of \$180.00 (1806) as set forth in 37 C.F.R. § 1.17(p) are also enclosed.
- ☐ Charge \_\_\_\_\_ to Deposit Account No. 02-4800 for the fee due.
- ☐ A check in the amount of \_\_\_\_\_ is enclosed for the fee due.
- ☐ Charge \_\_\_\_\_ to credit card. Form PTO-2038 is attached.

The Director is hereby authorized to charge any appropriate fees under 37 C.F.R. §§ 1.16, 1.17 and 1.21 that may be required by this paper, and to credit any overpayment, to Deposit Account No. 02-4800. This paper is submitted in duplicate.

Respectfully submitted,

BURNS, DOANE, SWECKER & MATHIS, L.L.P.

P.O. Box 1404  
Alexandria, Virginia 22313-1404  
(703) 836-6620

Date: July 19, 2005

By

  
Jeffrey G. Killian  
Registration No. 60,891



**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

|                             |   |                          |
|-----------------------------|---|--------------------------|
| In re Patent Application of | ) |                          |
| Otto Z. Zhou et al.         | ) | Group Art Unit: 1753     |
| Application No.: 09/996,695 | ) | Examiner: Kishor Mayekar |
| Filed: November 30, 2001    | ) | Confirmation No.: 1828   |
| For: DEPOSITION METHOD FOR  | ) |                          |
| NANOSTRUCTURE MATERIALS     | ) |                          |

**FOURTH INFORMATION DISCLOSURE STATEMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In accordance with the duty of disclosure as set forth in 37 C.F.R. § 1.56, the accompanying information is being submitted in accordance with 37 C.F.R. §§ 1.97 and 1.98.

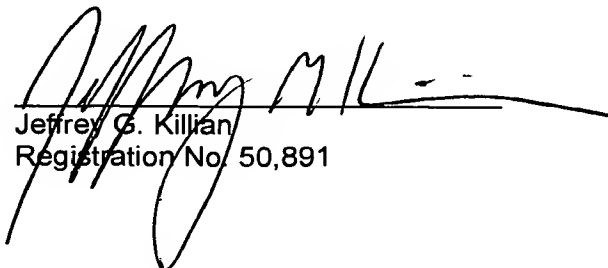
Enclosed is a copy of an International Search Report dated June 21, 2004 issued in connection with the corresponding International application. The references listed in the Search Report have been cited by the Examiner in an Official Action dated December 1, 2003 in the above-captioned application.

Respectfully submitted,

BURNS, DOANE, SWECKER & MATHIS, L.L.P.

Date July 19, 2005

P.O. Box 1404  
Alexandria, Virginia 22313-1404  
(703) 836-6620

By:   
Jeffrey G. Killian  
Registration No. 50,891